



2813/17W

DOCKET NO.: 4917

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Yasuyuki MATSUI et al.

| ART UNIT: 2811

SERIAL NO.: 10/552,275

| CONF. NO.: 4014

FILED: October 3, 2005

FOR: METHOD OF MANUFACTURING SINGLE-CRYSTAL BLOCKS FOR SLICING
OFF SEMICONDUCTOR WAFERS THEREFROM

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

April 3, 2007

STATUS REQUEST

Dear Sir:

Please inform us of the status of the processing of this
application in the USPTO.

Respectfully submitted
Yasuyuki MATSUI et al. - Applicant

WFF:ks/4917

Enclosure:
postcard

By W. F. Fasse
W. F. Fasse - Patent Attorney
Reg. No. 36132
Tel: 207 862 4671
Fax: 207 862 4681
P.O. Box 726
Hampden, Maine 04444-0726

CERTIFICATE OF MAILING:

I hereby certify that this correspondence with all indicated
enclosures is being deposited with the U. S. Postal Service with
sufficient postage as first-class mail, in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450, on the date indicated below.

Karin Smith - April 3, 2007

Name: Karin Smith - Date: April 3, 2007